

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent application of:

Applicant(s): Hung-Eil KIM

Serial No: 10/774,099

Filing Date: February 6, 2004

Title: MASK CD MEASUREMENT MONITOR OUTSIDE OF THE PELLICLE  
AREA

Examiner: John S. Ruggles

Art Unit: 1756

Docket No. AMDSPH1647US

**REPLY TO OFFICE ACTION DATED NOVEMBER 13, 2006**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Favorable reconsideration of the above-referenced application is respectfully requested in view of the following part(s) of this reply:

Amendments to the Specification  
Amendments to the Claims  
Amendments to the Abstract  
Remarks

In the event any fee or additional fee is due in connection with the filing of this paper, the Commissioner is authorized to charge those fees to our Deposit Account No. 18-0988 (under the above Docket Number). In the event an extension of time is needed to make the filing of this paper timely and no separate petition is attached, please consider this a petition for the requisite extension and charge the fee to our Deposit Account No. 18-0988 (under the above Docket Number).